IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application	on of:)
Koji ARITA et al.) Art Unit: 2812
Serial No. 09/938,528) Examiner: Unassigned
Filed: 08/27/2001)
For: METHOD FOR M	MANUFACTURING A)
SEMICONDUCT	OR DEVICE	`

CERTIFICATE OF MAILING

I hereby certify that this contesponding with sufficient postage as First Class Mail in 20, 20231, on 3/ I hereby certify that this correspondence is being deposited with the United States Postal Service velope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents and Trademarks

Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference(s) listed on the attached Form PTO-1449 be made of record in the above-identified application. Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

In accordance with 37 C.F.R. § 1.97(e), it is certified that either (1) each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this information disclosure statement, or (2) no item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign patent application and no item of information contained in the information disclosure statement was known to any individual designated in 37 C.F.R. § 1.56(c) more than three months prior to the filing of this information. disclosure statement.

740819-634 4/4/82

GAU/2812



COPY OF PAPERS ORIGINALLY FILED

Respectfully submitted,

Eric J. Robinson Reg. No. 38,285

NIXON PEABODY LLP 8180 Greensboro Drive, Suite 800 McLean, Virginia 22102 (703) 790-9110

MAR 22 2002
TECH CENTER 2800

MAR 22 2002